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Attorney's Docket No. 07977-017002	Express Mail Label No.	Mailing Date January 15, 2004	<b>For PTO Use Only</b> <i>Do Not Mark in This Area</i>
Application No. 09/451,665	Filing Date November 30, 1999	Attorney/Secretary Init JFH/WXH/adt	
Title of the Invention <b>SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF</b>			
Applicant <b>Shunpei Yamazaki, et al.</b>			
Client Reference No. US2968C1D1			
Enclosures			
<ul style="list-style-type: none"><li>• Check in the amount of \$110.00 (Check # 168187)</li><li>• One-Month Extension of Time (1 page)</li><li>• Reply to Action Dated September 15, 2003 (19 pages)</li><li>• Request for Initialed Form PTO-1449 (1 page)</li><li>• Form PTO-1449 (1 page)</li></ul>			

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